

Notice of References Cited	Application/Control No. 10/649,002	Applicant(s)/Patent Under Reexamination KIM, JAE-HWAN	
	Examiner Dai A. Phuong	Art Unit 2617	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0111139	08-2002	Nishiyama et al.	455/41
*	B	US-5,724,492	03-1998	Matthews et al.	345/419
*	C	US-2001/0006388	07-2001	Kim et al.	345/418
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
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FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
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NON-PATENT DOCUMENTS

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